

11082 U.S. PTO
10/09/75
02/19/02

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10079775	02/19/2002	438		2823	H Lee

**APPLICANTS: Plat Marina; Hui Angela;

**CONTINUING DATA VERIFIED: *Lee*
09/433,541 11/2/1999
THIS APPLICATION IS A DIV OF 09/433,541 11/03/1999

(*) Data inconsistent with PTO records.

Yes

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** FOREIGN APPLICATIONS VERIFIED: *Lee*
NONE

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	D900D/1368D
Verified and Acknowledged Examiners's initials <i>Lee</i>		
TITLE : Method and system for reducing ARC layer removal during removal of photoresist		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs.Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Applicati n Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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